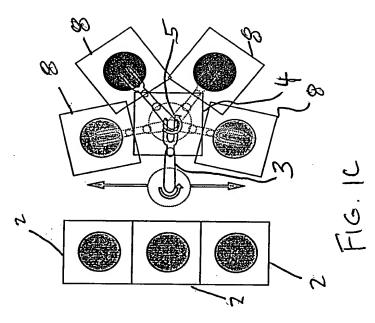
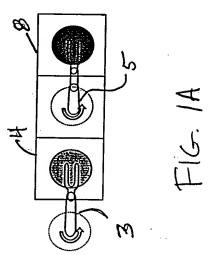
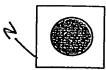
WAFER TRANSPORT SYSTEM AND METHOD YOO DOCKET NO. M-11439 US

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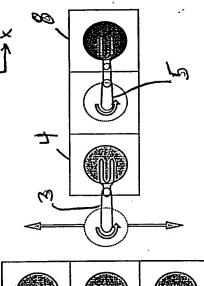
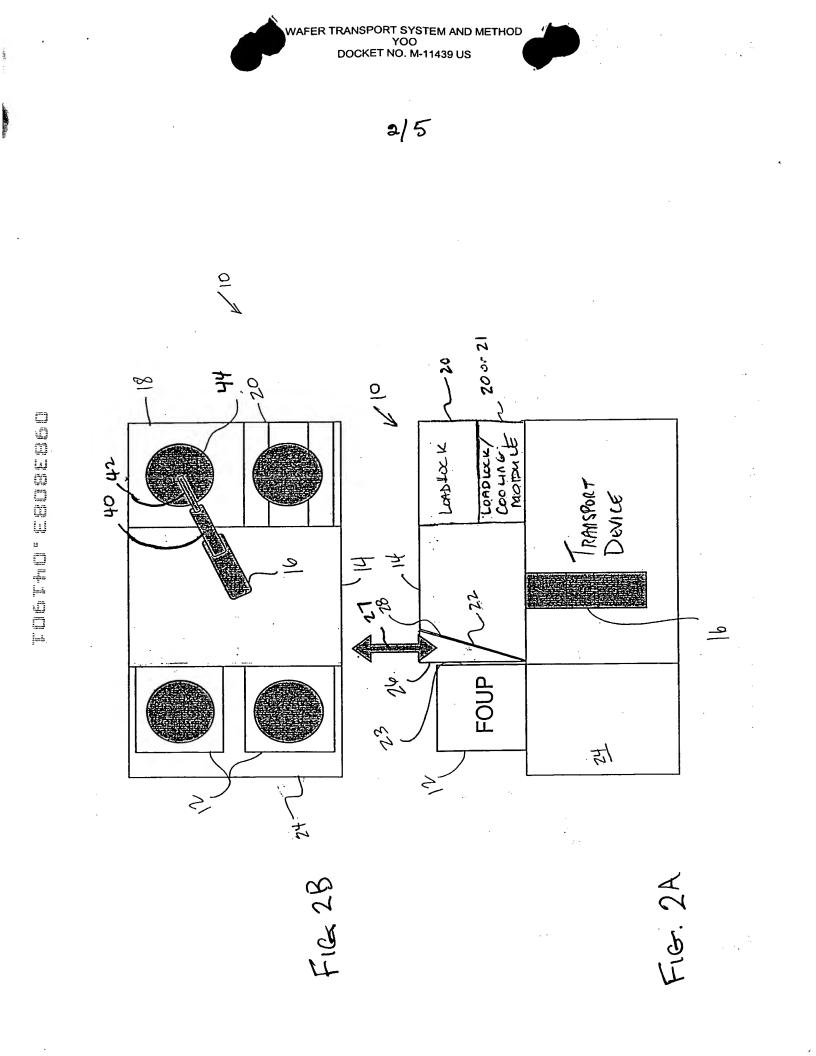


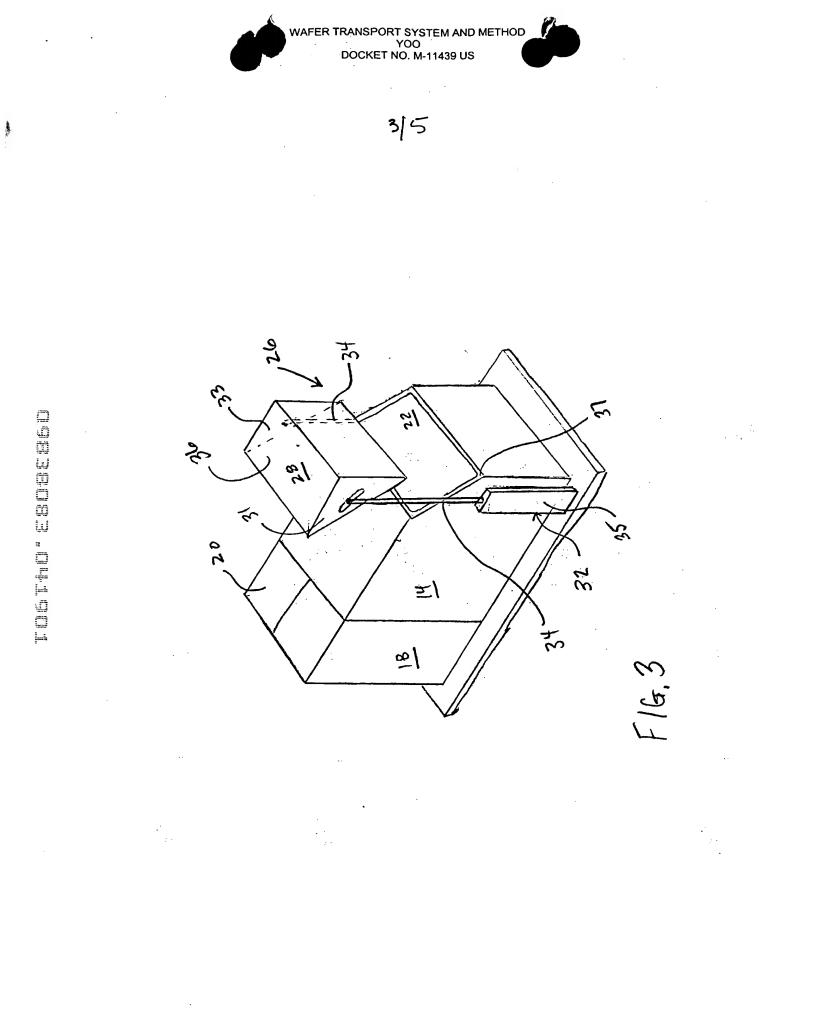
FIG IB



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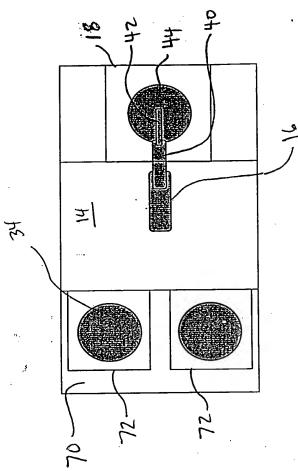


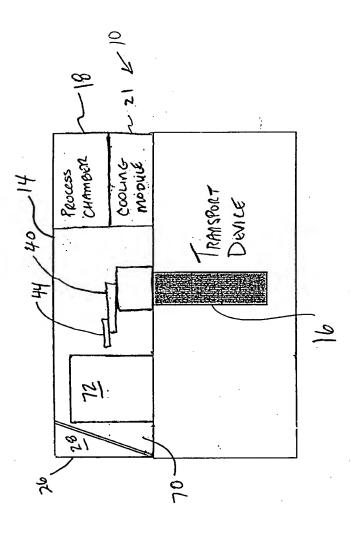
WAFER TRANSPORT SYSTEM AND METHOD YOO DOCKET NO. M-11439 US 4/5 50 1 ALIGN WAFER Container WITH 52 Processing System Extend TRUNSport Device into 54 Contriner and Remore WATERS Place Waters 56 INTO LEADLOCK ARE AND No. WAFERS 58 LOADED Z 64. Return writing lyes 10 Remove WAFER From Containen 60 LOUDIOCK UND PLACE THEWARDIN PRICESS FIG. 4 Renare worker Erlan 62-Pweess Charber and place it into tooling module

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WAFER TRANSPORT SYSTEM AND METHOD YOO DOCKET NO. M-11439 US









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